



Physical and Materials Constants

Boltzmann's constant	k	1.38×10^{-23}	J/K
Electron charge	q	1.6×10^{-19}	C
Thermal voltage	kT/q	0.026 (at $T = 300$ K)	V
Energy gap of silicon (Si)	E_{g}	1.12 (at $T = 300 \text{ K}$)	eV
Intrinsic carrier concentration of silicon (Si)	n_{i}	1.45×10^{10} (at $T = 300$ K)	cm ⁻³
Dielectric constant of vacuum	$oldsymbol{arepsilon}_0$	8.85×10^{-14}	F/cm
Dielectric constant of silicon (Si)	$\pmb{arepsilon}_{Si}$	$11.7 \times \epsilon_0$	F/cm
Dielectric constant of silicon dioxide (SiO ₂)	ϵ_{ox}	$3.97 \times \epsilon_0$	F/cm

Commonly Used Prefixes for Units

giga	G	10 ⁹
mega	M	10 ⁶
kilo	k	10^{3}
milli	m	10 ⁻³
micro	μ	10 ⁻⁶
nano	n	10 ⁻⁹
pico	р	10 ⁻¹²
femto	f	10 ⁻¹⁵



second edition

CMOS DIGITAL INTEGRATED CIRCUITS

Analysis and Design

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